



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Michael K. DENK et al. : Art Unit: 1621

Serial No.: 10/643,090 : Examiner: P. Nazario Gonzalez

Filed: August 19, 2003

For: A NEW CLASS OF VOLATILE

COMPOUNDS FOR THE DEPOSITION
OF THIN FILMS OF METALS AND

METAL COMPOUNDS

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the February 21, 2007 Office Action, please amend the above-identified application as follows.